

Scanning Electron Microscopes (SEM) at FEMR



- **Hitachi S-3000N Variable Pressure-SEM (VP-SEM) w/ Oxford INCA EDS and HKL EBSD**
- **Hitachi S-4700 Field Emission-STEM (FE-STEM) w/ Oxford INCA EDS**
- **JEOL JSM-840a SEM w/ EDAX EDS**

